OIPE JC76
JUL 26 2006
PATENT & TRADEMARK OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Woo-Sang Jang

Group Art Unit: 1763

Application No. 10/680,188

Examiner: Lund, Jeffrie Robert

Filed: October 8, 2003

For: A HIGH DENSITY PLASMA OXIDE FILM DEPOSITION APPARATUS HAVING A GUIDE RING AND A SEMICONDUCTOR DEVICE MANUFACTURING METHOD USING THE SAME

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria VA 22314

Sir:

In response to the Office Action of June 28, 2005, Applicant elects the invention of Group I, claims 1-8. The election is without traverse. However, Applicant does not in any way acquiesce to the Examiner's characterization of the invention of claims 1-8.

Respectfully submitted,

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